

▪ P25117.A01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Eiju KOMURO

Serial No : Not Yet Assigned

Filed : Concurrently Herewith

For : METHOD OF MANUFACTURING A PIEZOELECTRIC THIN FILM RESONATOR, MANUFACTURING APPARATUS FOR A PIEZOELECTRIC THIN FILM RESONATOR, PIEZOELECTRIC THIN FILM RESONATOR, AND ELECTRONIC COMPONENT

PRELIMINARY AMENDMENT

Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

Prior to the examination of the above-identified patent application on the merits, the Examiner is respectfully requested to amend the claims as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.